



10/675,572

**IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE**

Application No. : 10/675,572 Confirmation No. 9966  
Applicant : Gerald W. Gibson, Jr.  
Filed : September 30, 2003  
Group Art Unit : 2823  
Examiner : Fernando L. Toledo  
Docket No. : Gibson 12  
  
Title : Real Time Gate Etch Critical Dimension Control by Oxygen  
Monitoring

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action of October 18, 2006, please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 8 of this paper.